6th International Symposium on Advanced Optical Manufacturing and Testing Technologies

Optical System Technologies for Manufacturing and Testing

Xiangdi Lin
Yoshiharu Namba
Tingwen Xing
Editors

26–29 April 2012
Xiamen, China

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## Contents

<p>| | |</p>
<table>
<thead>
<tr>
<th></th>
<th></th>
</tr>
</thead>
<tbody>
<tr>
<td>ix</td>
<td>Symposium Committee</td>
</tr>
<tr>
<td>xi</td>
<td>Introduction</td>
</tr>
<tr>
<td>xiii</td>
<td>AOMATT 2012 Sponsors</td>
</tr>
</tbody>
</table>

### INVITED PAPER SESSION

<table>
<thead>
<tr>
<th>Session</th>
<th>Title</th>
<th>Authors and Affiliations</th>
</tr>
</thead>
<tbody>
<tr>
<td>8420 02</td>
<td>Advanced optical manufacturing digital integrated system [8420-68]</td>
<td>Y. Tao, X. Li, W. Li, D. Tang, Institute of Computer Application (China)</td>
</tr>
<tr>
<td>8420 03</td>
<td>Feedback control system for laser beam alignment [8420-58]</td>
<td>M. Li, J. Zhao, Q. Zang, Institute of Plasma Physics (China)</td>
</tr>
<tr>
<td>8420 04</td>
<td>Diffracted beam parameters of TE_0 mode symmetrical MQW planar waveguide [8420-66]</td>
<td>F. Guo, L. Li, H. Zheng, Fujian Normal Univ. (China)</td>
</tr>
<tr>
<td>8420 05</td>
<td>Using liquid crystal spatial light modulators with binary power spectrum in pattern recognition system [8420-141]</td>
<td>C. Liu, C. Chen, W. Liao, S. Fu, Yuan Ze Univ. (Taiwan)</td>
</tr>
<tr>
<td>8420 07</td>
<td>Camera calibration based on three-dimensional optical plate in close-range photogrammetry system [8420-59]</td>
<td>M. He, X. Gan, J. Li, X. Ye, National Institute of Metrology (China)</td>
</tr>
<tr>
<td>8420 08</td>
<td>Three-dimensional grid algorithm for all-sky autonomous star identification [8420-78]</td>
<td>W. Yi, H. Liu, J. Yang, H. Jia, L. Yang, National Univ. of Defense Technology (China)</td>
</tr>
<tr>
<td>8420 09</td>
<td>Diffractive pyramid wave-front sensor used for adaptive optics [8420-77]</td>
<td>Y. Zhao, X. Ding, K. Wang, H. Wei, Taiyuan Univ. of Science and Technology (China); H. Yang, Institute of Optics and Electronics (China); D. Cai, Taiyuan Univ. of Science and Technology (China)</td>
</tr>
</tbody>
</table>

### SESSION 8-1

<table>
<thead>
<tr>
<th>Session</th>
<th>Title</th>
<th>Authors and Affiliations</th>
</tr>
</thead>
<tbody>
<tr>
<td>8420 02</td>
<td>Advanced optical manufacturing digital integrated system [8420-68]</td>
<td>Y. Tao, X. Li, W. Li, D. Tang, Institute of Computer Application (China)</td>
</tr>
<tr>
<td>8420 03</td>
<td>Feedback control system for laser beam alignment [8420-58]</td>
<td>M. Li, J. Zhao, Q. Zang, Institute of Plasma Physics (China)</td>
</tr>
<tr>
<td>8420 04</td>
<td>Diffracted beam parameters of TE_0 mode symmetrical MQW planar waveguide [8420-66]</td>
<td>F. Guo, L. Li, H. Zheng, Fujian Normal Univ. (China)</td>
</tr>
<tr>
<td>8420 05</td>
<td>Using liquid crystal spatial light modulators with binary power spectrum in pattern recognition system [8420-141]</td>
<td>C. Liu, C. Chen, W. Liao, S. Fu, Yuan Ze Univ. (Taiwan)</td>
</tr>
<tr>
<td>8420 07</td>
<td>Camera calibration based on three-dimensional optical plate in close-range photogrammetry system [8420-59]</td>
<td>M. He, X. Gan, J. Li, X. Ye, National Institute of Metrology (China)</td>
</tr>
<tr>
<td>8420 08</td>
<td>Three-dimensional grid algorithm for all-sky autonomous star identification [8420-78]</td>
<td>W. Yi, H. Liu, J. Yang, H. Jia, L. Yang, National Univ. of Defense Technology (China)</td>
</tr>
<tr>
<td>8420 09</td>
<td>Diffractive pyramid wave-front sensor used for adaptive optics [8420-77]</td>
<td>Y. Zhao, X. Ding, K. Wang, H. Wei, Taiyuan Univ. of Science and Technology (China); H. Yang, Institute of Optics and Electronics (China); D. Cai, Taiyuan Univ. of Science and Technology (China)</td>
</tr>
</tbody>
</table>

### SESSION 8-2

<table>
<thead>
<tr>
<th>Session</th>
<th>Title</th>
<th>Authors and Affiliations</th>
</tr>
</thead>
<tbody>
<tr>
<td>8420 02</td>
<td>Advanced optical manufacturing digital integrated system [8420-68]</td>
<td>Y. Tao, X. Li, W. Li, D. Tang, Institute of Computer Application (China)</td>
</tr>
<tr>
<td>8420 03</td>
<td>Feedback control system for laser beam alignment [8420-58]</td>
<td>M. Li, J. Zhao, Q. Zang, Institute of Plasma Physics (China)</td>
</tr>
<tr>
<td>8420 04</td>
<td>Diffracted beam parameters of TE_0 mode symmetrical MQW planar waveguide [8420-66]</td>
<td>F. Guo, L. Li, H. Zheng, Fujian Normal Univ. (China)</td>
</tr>
<tr>
<td>8420 05</td>
<td>Using liquid crystal spatial light modulators with binary power spectrum in pattern recognition system [8420-141]</td>
<td>C. Liu, C. Chen, W. Liao, S. Fu, Yuan Ze Univ. (Taiwan)</td>
</tr>
<tr>
<td>8420 07</td>
<td>Camera calibration based on three-dimensional optical plate in close-range photogrammetry system [8420-59]</td>
<td>M. He, X. Gan, J. Li, X. Ye, National Institute of Metrology (China)</td>
</tr>
<tr>
<td>8420 08</td>
<td>Three-dimensional grid algorithm for all-sky autonomous star identification [8420-78]</td>
<td>W. Yi, H. Liu, J. Yang, H. Jia, L. Yang, National Univ. of Defense Technology (China)</td>
</tr>
<tr>
<td>8420 09</td>
<td>Diffractive pyramid wave-front sensor used for adaptive optics [8420-77]</td>
<td>Y. Zhao, X. Ding, K. Wang, H. Wei, Taiyuan Univ. of Science and Technology (China); H. Yang, Institute of Optics and Electronics (China); D. Cai, Taiyuan Univ. of Science and Technology (China)</td>
</tr>
</tbody>
</table>
Lenses matching of compound eye for target positioning [8420-91]
F. Guo, Univ. of Science and Technology (China); Y. Zheng, Univ. of Science and Technology of China (China); K. Wang, Univ. of Science and Technology (China)

Observing high-frequency optical turbulence properties by the usage of fiber optical turbulence sensing system [8420-36]
Q. Huang, Anhui Institute of Optics and Fine Mechanics (China) and Graduate Univ. of Chinese Academy of Sciences (China); H. Mei, Anhui Institute of Optics and Fine Mechanics (China); S. Xiao, Anhui Institute of Optics and Fine Mechanics (China) and Graduate Univ. of Chinese Academy of Sciences (China); R. Rao, Anhui Institute of Optics and Fine Mechanics (China)

Optical design method of freeform lens for a high-power extended LED source [8420-90]
H. Wang, South China Univ. of Technology (China) and Georgia Univ. of Technology (United States); N. Du, Y. Wu, H. Huang, South China Univ. of Technology (China)

Image reconstruction model for the collinear holographic data storage system [8420-75]
J. Li, L. Cao, Q. He, G. Jin, Tsinghua Univ. (China)

Study of the modulation characterization of phase-only liquid crystal spatial light modulator by digital holography [8420-57]
S. Panezai, D. Wang, J. Zhao, Y. Wang, Beijing Univ. of Technology (China)

Performance analysis of a volume holographic correlator based opto-electronic hybrid system for scene matching [8420-64]
T. Zhao, L. Cao, T. Zheng, S. Wang, Q. He, G. Jin, Tsinghua Univ. (China)

Research on reconstruction of spatial density distribution using optical interferometry and tomography [8420-70]
T. Ling, D. Liu, C. Tian, L. Sun, Y. Yang, Zhejiang Univ. (China)

Study on the nonlinear polarization rotation law in a bulk semiconductor optical amplifier in a pump-probe scheme [8420-82]
X. Feng, National Univ. of Defense Technology (China) and Information Engineering Univ. (China); J. Ji, W. Dou, National Univ. of Defense Technology (China); G. Zhang, Information Engineering Univ. (China)

Principle and implementation of thousands-trit ternary optical encoder [8420-178]
Z. Shen, L. Wu, Luoyang Normal Univ. (China); S. Ouyang, Shanghai Univ. (China)

Characters analysis of the atmospheric turbulence vertical distribution profile over desert [8420-18]
Y. Hu, K. Wang, Z. Zhang, S. Feng, M. Wu, 63655 Unit, People’s Liberation Army (China)

Method of information hiding based on the theory of wavelet transform [8420-37]
Z. Ma, W. Hua, X. Li, Y. Zhang, Mechanical Engineering College (China)
| 8420 0M | **Parameter optimization of Dome A site testing DIMM by data mining** [8420-46]  
L. Xu, Nanjing Institute of Astronomical Optics & Technology (China); C. Pei, Nanjing Institute of Astronomical Optics & Technology (China) and Graduate Univ. of Chinese Academy of Sciences (China) |
| 8420 0N | **Coupling efficiency analysis of a gradient-index planar waveguide coupler based on ABCD matrix** [8420-56]  
X. Kong, Naval Univ. of Engineering (China); H. Cao, Hubei Normal Univ. (China); Q. Hu, X. Lei, Naval Univ. of Engineering (China) |
| 8420 0O | **Research on identification of moving targets in space** [8420-67]  
T. Xu, G. Zhang, W. Xu, G. Jin, Changchun Institute of Optics, Fine Mechanics and Physics (China) |
| 8420 0P | **Thermal management for CCD performance of one space telescope** [8420-27]  
W. Yang, Y. Wang, L. Feng, C. Wang, G. Ren, W. Wang, C. Li, W. Gao, X. Fan, Xi’an Institute of Optics and Precision Mechanics (China) |
| 8420 0Q | **Design of superresolving continuous phase filter with radially polarized light beam** [8420-81]  
H. Chen, Y. Liu, T. Liu, China Jiliang Univ. (China) |
| 8420 0R | **Beforehand alarm system against vehicle rear-end accident based on laser sensor** [8420-20]  
J. Li, L. Wang, X. Gao, Z. Wang, Q. Zhao, Southwest Jiaotong Univ. (China) |
| 8420 0S | **Remote sensing image stitch using modified structure deformation** [8420-19]  
K. Pan, J. Chen, Y. Chen, H. Feng, Zhejiang Univ. (China) |
| 8420 0T | **Segment and spline synthesis optimization method for LED based freeform total-internal-reflection lens design** [8420-32]  
E. Chen, Z. Zhuang, J. Cai, Y. Liu, F. Yu, Zhejiang Univ. (China) |
| 8420 0U | **Design of speaker recognition system based on artificial neural network** [8420-21]  
Y. Chen, L. Wang, H. Lin, J. Li, Southwest Jiaotong Univ. (China) |
| 8420 0V | **Defocus insensitive projection lens for CF-LCOS pico-projector** [8420-31]  
P. Liu, Q. Liu, F. Yu, Zhejiang Univ. (China) |
| 8420 0W | **Study on MTF of remote sensing imaging under arbitrary known vibration** [8420-9]  
Q. Deng, H. Feng, Z. Xu, Q. Li, Y. Chen, W. Dong, Zhejiang Univ. (China) |
| 8420 0X | **Research on the accuracy of spectral calibration using atmospheric absorption features with different water vapor contents** [8420-5]  
L. Li, Shanghai Institute of Technical Physics (China) and Graduate Univ. of Chinese Academy of Sciences (China); Y. Hu, C. Gong, Y. Wang, X. Ding, Shanghai Institute of Technical Physics (China); H. He, L. Zhu, China Ctr. for Resources Satellite Data and Application (China) |
| 8420 0Y | **Lateral shearing interferometry applied for phase measurement in wavefront coherent synthesis** [8420-51]  
Y. Hu, Beijing Institute of Technology (China); W. Wang, Beihang Univ. (China) |
8420 02  **Improved color interpolation method based on Bayer image** [8420-40]
   J. Wang, Institute of Optics and Electronics (China) and Univ. of Electronic Science and Technology of China (China)

8420 10  **Novel geometric correction method of distorted image** [8420-41]
   J. Wang, Institute of Optics and Electronics (China) and Univ. of Electronic Science and Technology of China (China)

8420 11  **Experimental study of photo counting imaging based on APD** [8420-26]
   H.-M. Qu, Y. Li, D. Cao, Q. Zheng, Z.-J. Ji, Q. Chen, Nanjing Univ. of Science and Technology (China)

8420 12  **A novel auto-focus function** [8420-12]
   J. Wang, Institute of Optics and Electronics (China) and Graduate Univ. of Chinese Academy of Sciences (China); H. Chen, Institute of Optics and Electronics (China)

8420 13  **Non-uniformity correction algorithm for decomposing the non-uniformity character of infrared FPA** [8420-88]
   H. Ming, Air Defense Forces Command Academy (China); Y.-D. Wang, Information Engineering Univ. of the People's Liberation Army (China); X. Wang, J. Lu, Y. Liu, Air Defense Forces Command Academy (China); Y. Zhu, Information Engineering Univ. of the People's Liberation Army (China)

8420 14  **Second-order moment estimation of pointing errors in laser pointing system using return photons** [8420-28]
   L. Zhou, Institute of Optics and Electronics (China) and Graduate Univ. of Chinese Academy of Sciences (China); G. Ren, Y. Tan, Institute of Optics and Electronics (China)

8420 15  **Analysis of noise tolerance for high precision tilting measurement algorithm of moving mirror in Fourier transform infrared spectrometer** [8420-55]
   X. Sun, Shanghai Institute of Technical Physics (China) and Graduate Univ. of Chinese Academy of Sciences (China); J. Mao, Shanghai Institute of Physical Education (China); Z. Dai, Shanghai Institute of Technical Physics (China); X. Xia, T. Li, Z. Wang, Shanghai Institute of Technical Physics (China) and Graduate Univ. of Chinese Academy of Sciences (China)

8420 16  **Real-time visual simulation of APT system based on RTW and Vega** [8420-11]
   S. Xiong, Institute of Optics and Electronics (China) and Graduate Univ. of Chinese Academy of Sciences (China); C. Fu, T. Tang, Institute of Optics and Electronics (China)

8420 17  **Design of computer-generated holographic diffraction optics element used for holographic sight** [8420-23]
   Y. Liu, Z. Li, H. Li, P. Li, Y. Ding, Academy of Armored Force Engineering (China)

8420 18  **Motion blurred image restoration based on Hartmann-Shack wavefront sensor** [8420-7]
   Y. Yu, W. Dong, H. Feng, Z. Xu, Q. Li, Zhejiang Univ. (China)

8420 19  **New technique for enhancement of high dynamic range infrared images** [8420-89]
   Y. Liu, Zhejiang Univ. (China); X. Wang, H. Xu, M. He, M. Li, Air Defense Forces Command Academy (China)
<table>
<thead>
<tr>
<th>Session</th>
<th>Title</th>
<th>Authors</th>
</tr>
</thead>
<tbody>
<tr>
<td>8420 1A</td>
<td>Simulation and test platform for free-space quantum communication [8420-63]</td>
<td>H. Jiang, J. Jia, J. Wang, Shanghai Institute of Technical Physics (China)</td>
</tr>
<tr>
<td>8420 1B</td>
<td>Simulations and experiments on optical focusing characteristics using an imaging fiber bundle [8420-85]</td>
<td>Y. Wan, H. Chen, T. Man, Y. Wang, Z. Jiang, D. Wang, Beijing Univ. of Technology (China)</td>
</tr>
<tr>
<td>8420 1C</td>
<td>Influence of illumination mode to lithographic imaging [8420-2]</td>
<td>Y. Liu, Institute of Optics and Electronics (China) and Graduate Univ. of Chinese Academy of Sciences (China); T. Xing, X. Yang, Institute of Optics and Electronics (China)</td>
</tr>
<tr>
<td>8420 1E</td>
<td>Color reconstruction of medium infrared polarization images based on HSV and wavelet packet transform [8420-80]</td>
<td>W. Chen, S. Wang, Science and Technology on Optical Radiation Lab. (China); W. Jin, X. Wang, Beijing Institute of Technology (China)</td>
</tr>
<tr>
<td>8420 1F</td>
<td>Multifocus image fusion algorithm based on the contourlet transform [8420-10]</td>
<td>L. Yang, Graduate Univ. of Chinese Academy of Sciences (China) and Xi’an Institute of Optics and Precision Mechanics (China); J. Cao, H. Wang, Y. Tang, H. Wang, Xi’an Institute of Optics and Precision Mechanics (China)</td>
</tr>
<tr>
<td>8420 1G</td>
<td>Optimizing design of progressive addition lenses [8420-39]</td>
<td>L. Qin, C. Zeng, L. Qian, J. Yu, Soochow Univ. (China)</td>
</tr>
<tr>
<td>8420 1H</td>
<td>Fuzzy-PID control for airborne optoelectronic stabilized platform [8420-53]</td>
<td>L. Liu, Changchun Institute of Optics, Fine Mechanics and Physics (China) and Graduate Univ. of Chinese Academy of Sciences (China); H. Shen, Changchun Institute of Optics, Fine Mechanics and Physics (China)</td>
</tr>
<tr>
<td>8420 1I</td>
<td>Saliency map based active contour method for automatic image segmentation [8420-42]</td>
<td>C. Yang, Huazhong Univ. of Science and Technology (China); X. Zheng, China Three Gorges Univ. (China); S. Qi, J. Tian, Huazhong Univ. of Science and Technology (China); S. Zheng, China Three Gorges Univ. (China)</td>
</tr>
<tr>
<td>8420 1J</td>
<td>Analysis on the tolerance of continuous phase plate [8420-16]</td>
<td>C. Yang, Y. Zhang, J. Wan, L. Yang, Chengdu Fine Optical Engineering Research Ctr. (China)</td>
</tr>
<tr>
<td>8420 1K</td>
<td>S+C+L ultra-broadband light source research [8420-1]</td>
<td>C. Xi, Jiaxing Univ. (China)</td>
</tr>
<tr>
<td>8420 1L</td>
<td>Effect of wet chemical treatment on BK-7 substrate [8420-83]</td>
<td>X. Ye, T. Ding, X. Cheng, B. Ma, Z. Shen, J. Zhang, Tongji Univ. (China); H. Liu, Y. Ji, Jinhang Institute of Technology Physics (China); Z. Wang, Tongji Univ. (China)</td>
</tr>
</tbody>
</table>
Application of ASAP in integral imaging [8420-182]
H. Wang, Z. Xu, S. Wen, Beijing Youth Politics College (China); C. Wu, Univ. of Science and Technology Beijing (China)

Author Index
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<table>
<thead>
<tr>
<th>Session 1-1</th>
<th>Fan Wu</th>
<th>Session 3-2</th>
<th>Sandy To</th>
</tr>
</thead>
<tbody>
<tr>
<td>Session 2-1</td>
<td>Qiming Xin</td>
<td>Session 4-2</td>
<td>Yanqiu Li</td>
</tr>
<tr>
<td>Session 3-1</td>
<td>Shangming Wen</td>
<td>Session 5-2</td>
<td>Hui Lin</td>
</tr>
<tr>
<td>Session 4-1</td>
<td>Xuefeng Liu</td>
<td>Session 7-1</td>
<td>Shangming Wen</td>
</tr>
<tr>
<td>Session 5-1</td>
<td>Lei Zhang</td>
<td>Session 8-2</td>
<td>Tingwen Xing</td>
</tr>
<tr>
<td>Session 6-1</td>
<td>Rongzhu Zhang</td>
<td>Session 2-3</td>
<td>Qiming Xin</td>
</tr>
<tr>
<td>Session 8-1</td>
<td>Tingwen Xing</td>
<td>Session 3-3</td>
<td>Shangming Wen</td>
</tr>
<tr>
<td>Session 1-2</td>
<td>Bin Fan</td>
<td>Session 5-3</td>
<td>Zhu Ma</td>
</tr>
<tr>
<td>Session 2-2</td>
<td>Rongzhu Zhang</td>
<td></td>
<td></td>
</tr>
</tbody>
</table>
Introduction

The 6th International Symposium on Advanced Optical Manufacturing and Testing Technology (AOMATT) was held 26–29 April 2012 at the Xiamen International Conference Center, Xiamen, China.

AOMATT 2012 was kicked off on April 26 with a formal opening ceremony. The ceremony started with the introduction of VIP guests, symposium chairs, and conference chairs, followed by opening speeches by Prof. Liwei Zhou, AOMATT 2012 Symposium Chairman, Prof. Bin Xu, Vice President of IOE, sponsor of AOMATT2012, and Dr. H. Philip Stahl, Vice President of SPIE, technical cosponsor of AOMATT2012. Plenary sessions started immediately after the conclusion of the opening ceremony. There were a total of 10 plenary presentations: Dr. H. Philip Stahl, 2012 SPIE Vice President and NASA Marshall Space Flight Center (USA); Prof. Hiroki Kuwano, 2012 President of Japanese Mechanics Society and Director of Micro/Nano Center, Tohoku University (Japan); Dr. Fritz Klocke, President of Fraunhofer Institute for Production Technology IPT (Germany); Dr. James Burge, Professor of Optical Sciences and Astronomy at the University of Arizona (USA); Dr. Eric Ruch , SAGEM (France); Dr. Tilmann Heil, Director of System Engineering, Carl Zeiss SMT GmbH (Germany); Prof. W. B. Lee, Professor of Manufacturing Engineering and Director of Advanced Technology Manufacturing Research Centre, Hong Kong Polytechnic University; Dr Fengzhou Fang, Professor of Precision Measurement Technology and Instruments at Tianjin University (China); Prof. Shengyi Li, Professor of Mechatronics and Automation at the National University of Defense Technology (China). More than 1,000 people attended the opening ceremony and full-day plenary sessions.

More than 1,000 abstracts were submitted to AOMATT2012, and from these about 500 oral and poster papers were selected. Oral papers were presented in 8 parallel conferences on April 27 and 28. An all-symposium poster session was held in the afternoon of April 28. All of the parallel conference sessions and the poster session were well attended. Authors and attendees had active discussions and exchange of ideas throughout the symposium. Many papers presented cutting-edge research and development work in optical design, manufacturing, and testing. The success of AOMATT2012 continued the tradition of focus and excellence of this biannual international topical symposium in China.

We would like to express our sincere appreciation to COS - The Chinese Optical Society, IOE - Institute of Optics and Electronics, Chinese Academy of Sciences, and SPIE for sponsoring and supporting AOMATT2012. We want to thank all authors and participants for their contributions to the symposium and sharing their research with colleagues around the world. The 7th AOMATT is planned for 2014.
We look forward to seeing everyone at AOMATT2014. Please watch for the Call for Papers and symposium announcements on SPIE and IOE web sites.

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